

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Han et al.	Group Art Unit: 1775
Application No: 10/824,123	Examiner: Michael E. Lavilla
Confirmation No: 6448	Attorney Docket No:
Filed: April 13 th , 2004	003330 P01 USA/ETCH/METAL/MD
Title: PROCESS CHAMBER COMPONENT HAVING ELECTROPLATED YTTRIUM CONTAINING COATING	July 10 th , 2007 San Francisco, California

AMENDMENT IN RESPONSE TO FINAL OFFICE ACTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

VIA ELECTRONIC FILING

Examiner Lavilla:

This communication is in response to the Office Communication mailed on April 5th, 2007, and is being filed with a petition for a one-month extension of time and authorization to charge deposit account for the requisite fee of \$120 under 37 C.F.R. § 1.17(a)(1).